

EX-QS Wafer Mapping Sensors

Instructions for Installation and Use

EX-43QS

EX-73QS



Email: CSsupport@cyberoptics.com
For information about CyberOptics'
offices and global support network,
please visit www.cyberoptics.com.



CAUTIONS:

The semiconductor laser used in EX-QS wafer mapping sensors generates Class 1 invisible laser radiation. Laser light emanates from front face of sensor. Avoid direct viewing or staring into the laser beam. These devices meet the standards required by the Center for Devices and Radiological Health (CDRH) of the U.S. Food and Drug Administration.

Use of controls or adjustments or performance of procedures other than those specified herein may result in hazardous radiation exposure.

EX-QS sensors contain no user-serviceable parts. Refer all servicing to an authorized CyberOptics Semiconductor agent.

These sensors conform to IEC 60825-1 (2001-08) (laser safety) and to the laser safety requirements of SEMI S2-0200.

Careful installation and alignment of the sensor is required for optimal performance. Read the instructions before installation.

These instructions are required for successful operation of the sensor. They should be transmitted to the end user in the case of OEM installation of the sensor.



Class 1 Laser Product Label

Technical Support

Providing responsive technical support for our products is a top priority for CyberOptics. We have a dedicated technical support group available to answer your questions Monday through Friday, 7 a.m. - 5 p.m. (Pacific Time).

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For non-support inquiries please e-mail CSinfo@Cyberoptics.com.